

METAL NANOPARTICLES AND METHOD FOR  
MANUFACTURING SAME

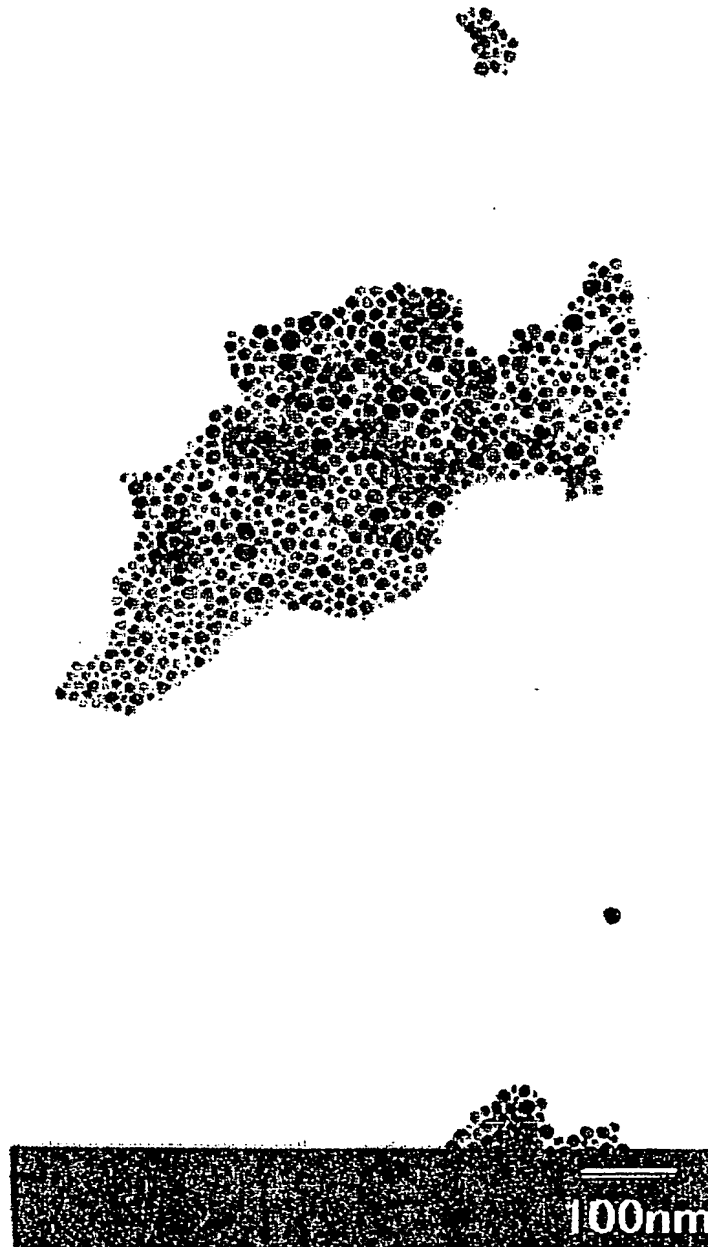
NAKAMOTO, et al.

Appl. No.: Unknown

Atty Docket: SAEG178.001APC

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Fig. 1



METAL NANOPARTICLES AND METHOD FOR  
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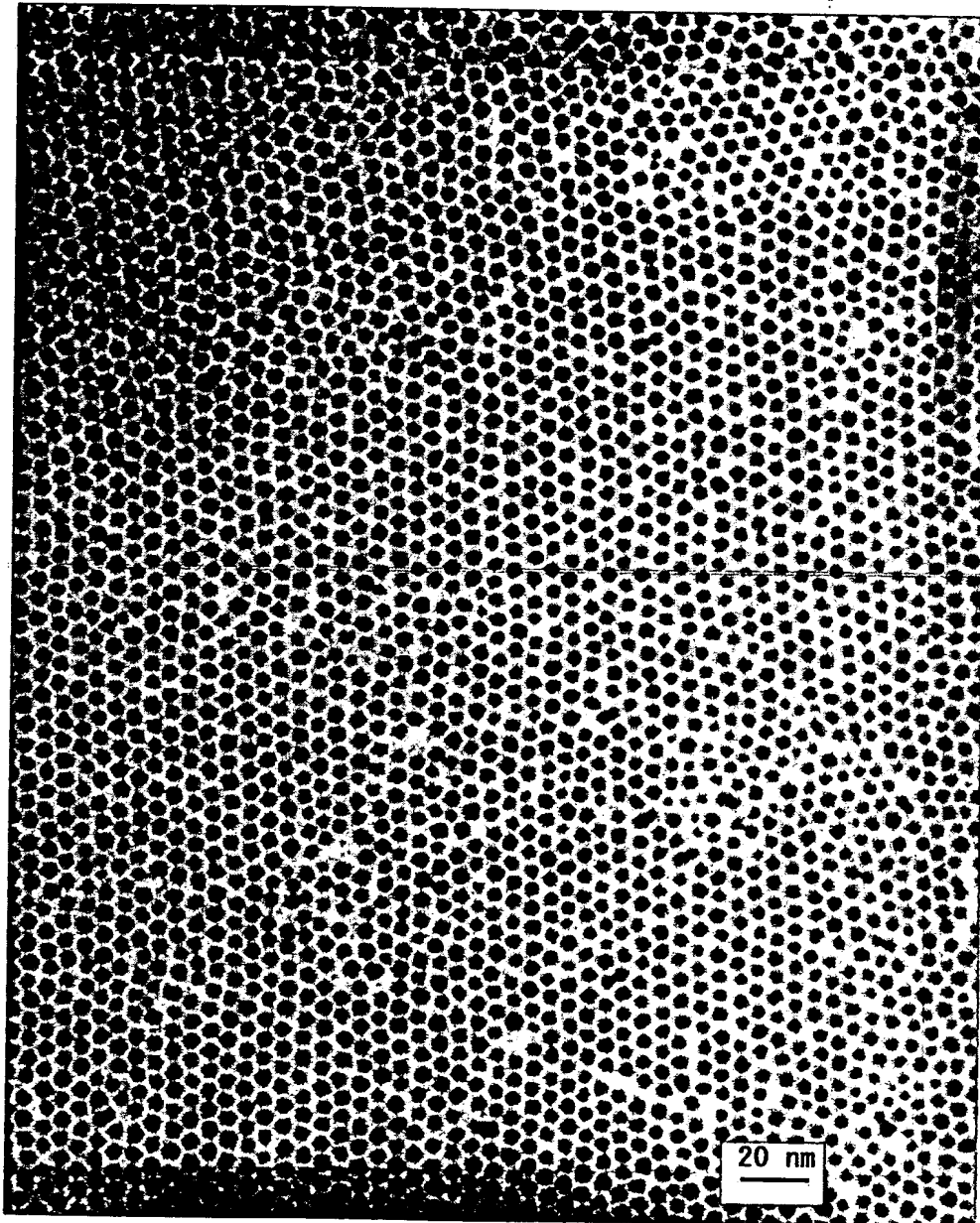
NAKAMOTO, et al.

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Fig. 2



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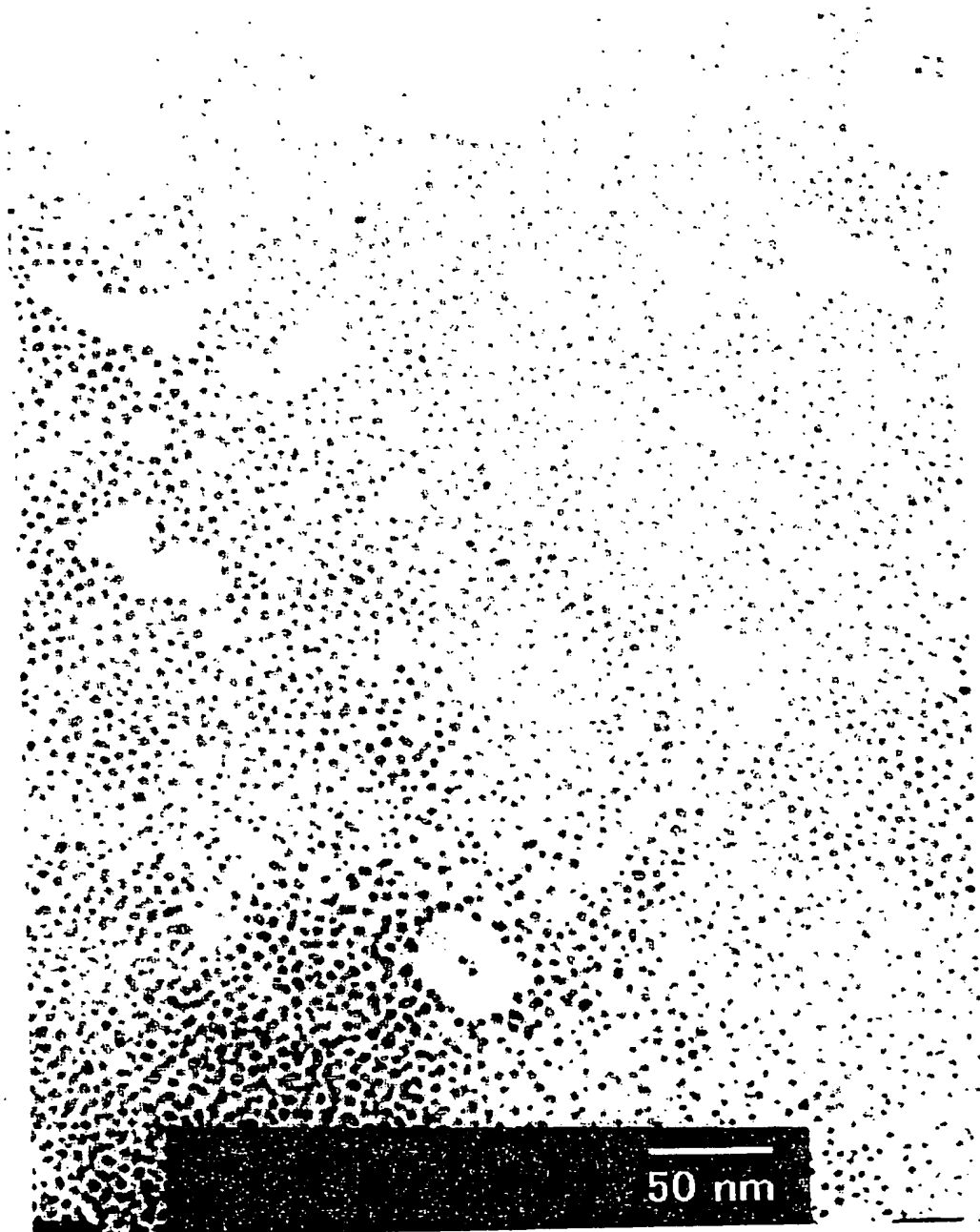
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Fig. 3



METAL NANOPARTICLES AND METHOD FOR  
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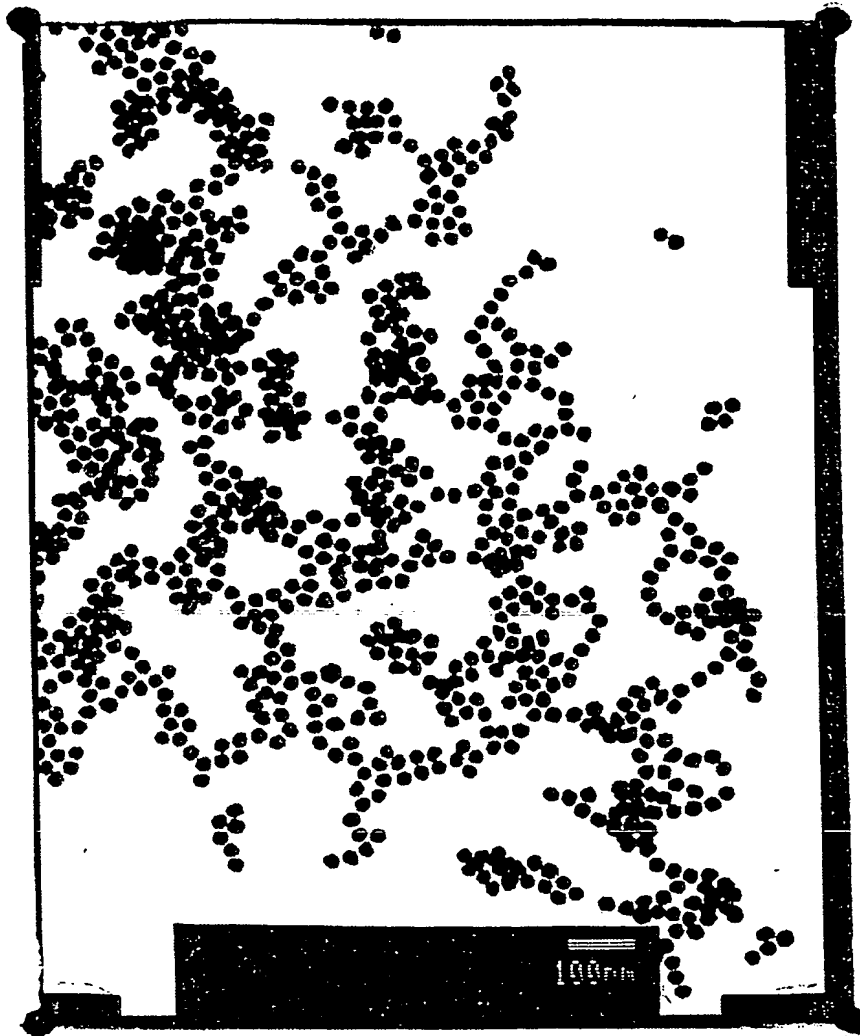
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Fig. 4



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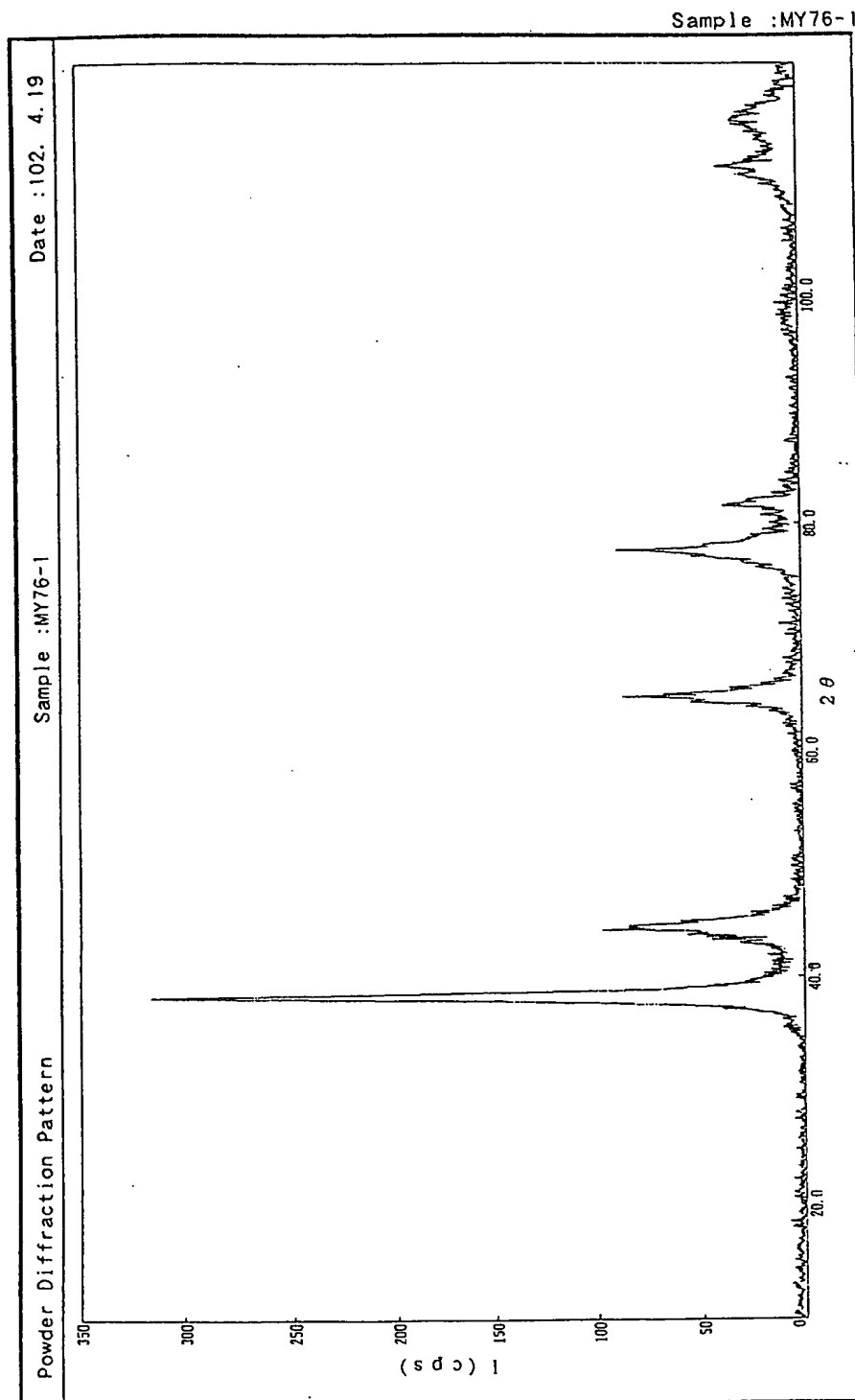
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Fig. 5



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Sample	M76-1		File name	yamamoto/M76-1	[2]:Kα2 Subtract	Orig [1]:Smooth
X-ray generator	18KV		Smoothing			
Target	1.54056 Å (Cu)		Data points	: 7	Data points	: 0
Monochromator	use		Threshold	: 1.00	Threshold	: 0
KV	40.0		Background subtraction			
mA	50.0		Data points	: 0	Operator	
Sampling Width	0.0200 deg		Repeating times	: 0	Measuring Date	: 102 4 19 14:10:5
Scanning Speed	4.0000 deg/min		Comment			

Fig. 6

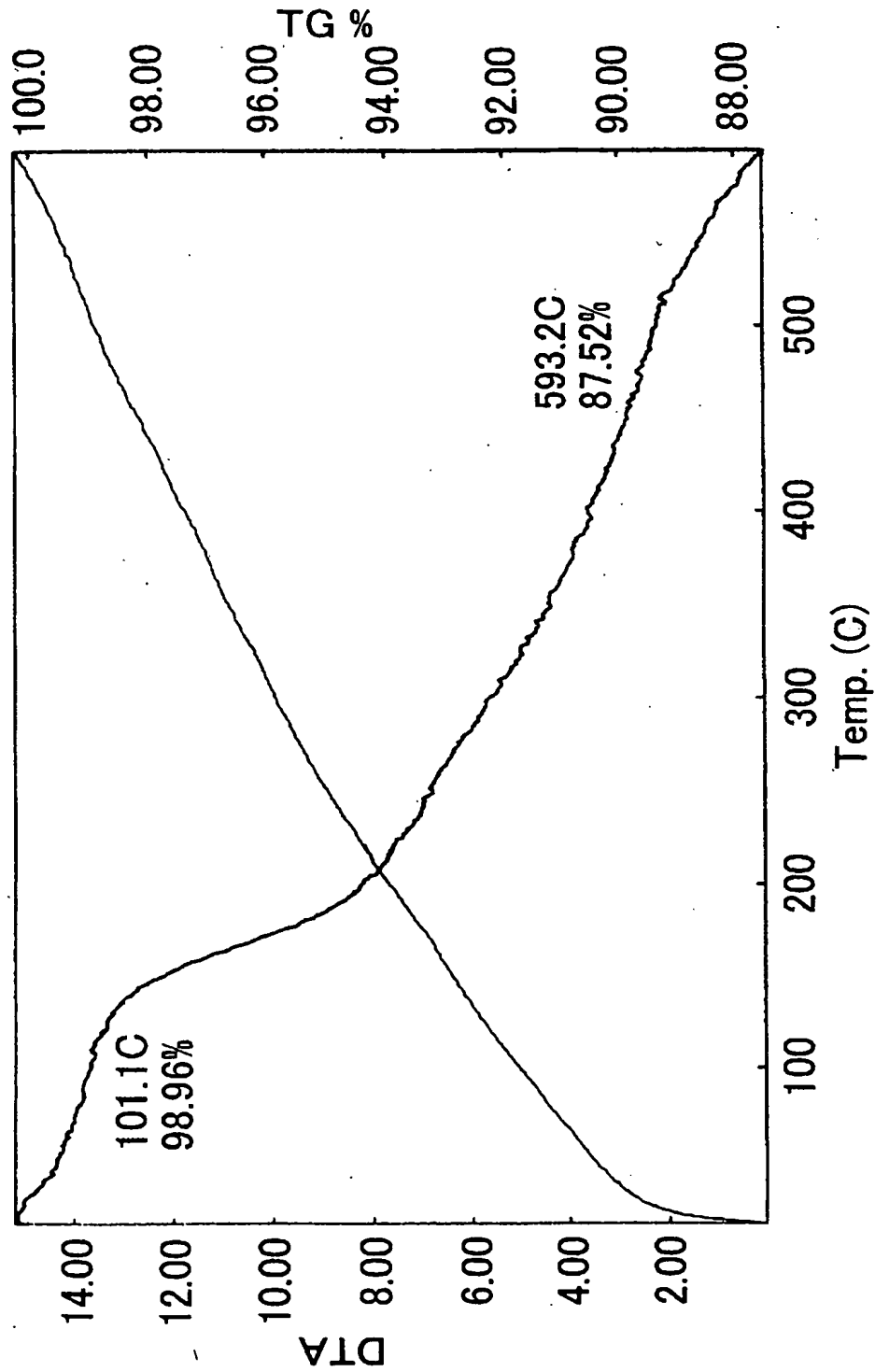
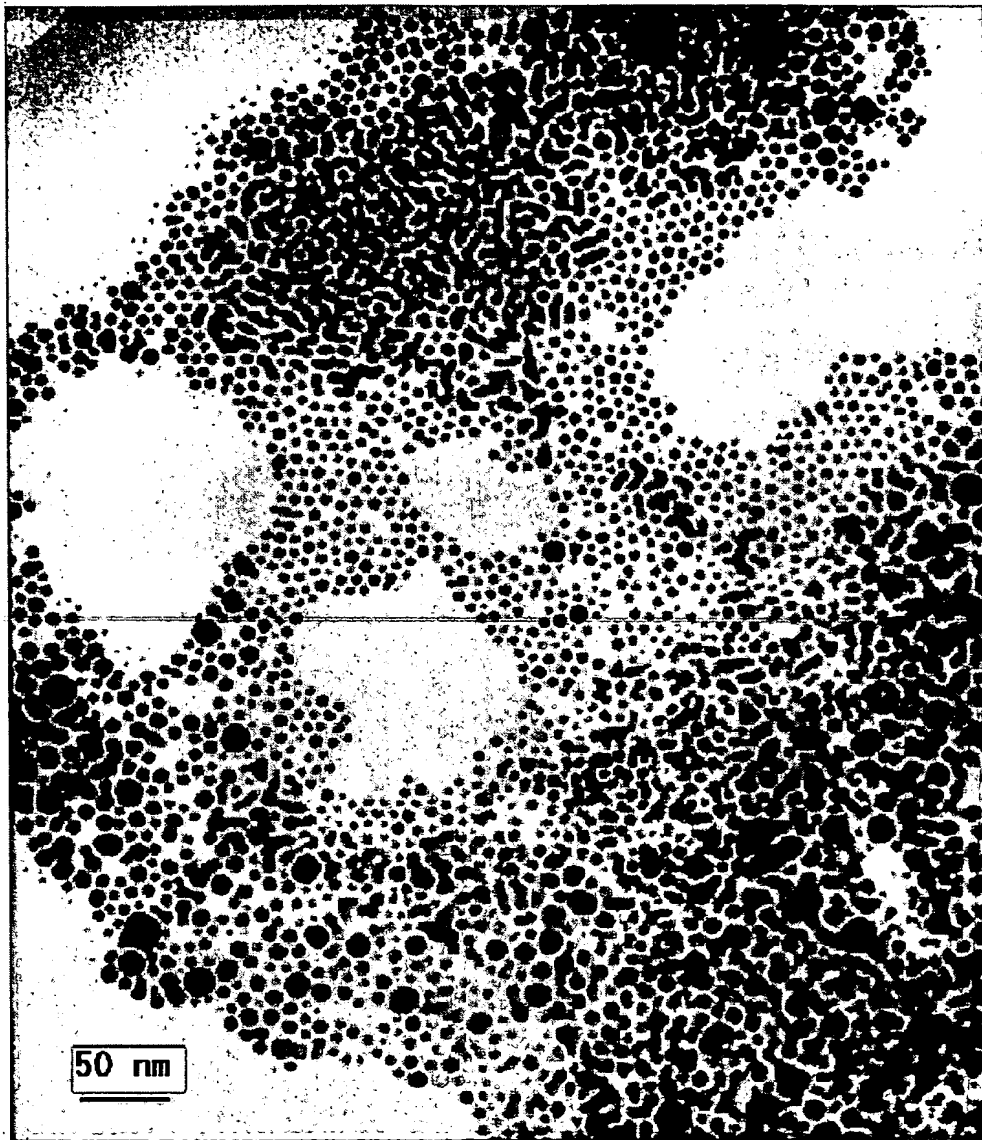


Fig. 7





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Fig. 8

